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Substitute f rF rm 1449/PTO INFORMATION DISCLARMENTE						Application Number	10/626,257		
INFURIVIATION DIOCEMASSICE						Filing Date	July 23, 2003		
STATEMENT BY APPLICANT (use as many sheets as necessary)						First Named Inventor:	Anand Murthy		
						Art Unit	2811		
						Examiner Name		Not Yet Assigned SOWARD	
Sheet	1		of	1.		Attorney Docket Number	042390.P9490C		
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Examiner Initials*	Cite No Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published								T ²
(1)	Q. Ouyang, et al. "Two-Dimensional Bandgap Engineering in a Novel Si/SiGe pMOSFET With Enhanced Device Performance and Scalability," IEEE 2000. 0-7803-6279-9/00, pp. 151-154.								
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A	An Steegen, et al. "Silicide induced pattern density and orientation dependent transconductance in MOS transistors," IEEE 1999. IMEC, Belgium and INSYS, Belgium 0-7803-5410-9/99, pp. 20.1.1-20.1.4.							ium.	
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*Examiner: Initial II reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 'Applicant's unique citation designation number (optional). 'Applicant is to place a check mark here if English translation to applicant.

Is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to This collection of information is required by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete including gathering, preparing, and process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this submitting the complete day. The complete this process of the complete this collection is estimated to take 2 hours to complete including gathering, preparing, and process of the complete this collection is estimated to take 2 hours to complete including gathering, preparing, and the complete this collection is estimated to take 2 hours to complete this collection is estimated to take 2 hours to complete this collection is estimated to take 2 hours to complete including gathering, and the complete including gathering to complete including gathering, and the complete including gathering, and the complete including gathering the complete including gathering, and the complete including gathering gath